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<p>Sheet</p>		<p>1</p>	<p>of</p>	<p>6</p>	<p>Application Number</p>	<p>Herewith</p>
<p>Filing Date</p>						
<p>First Named Inventor</p>				<p>Chen et al</p>		
<p>Group Art Unit</p>						
<p>Examiner Name</p>						
				<p>Attorney Docket Number</p>	<p>100202586-5</p>	

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (# known)			
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	20020075554	A1		Brophy et al.	06-20-2002	
	20020070723	A1		Herbert et al.	06-13-2002	
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				Filing Date	
				First Named Inventor	Chen et al
				Group Art Unit	
				Examiner Name	
Sheet	2	of	6	Attorney Docket Number	100202586-5

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.*	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document* MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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¹ Unique citation designation number. ² See attached *Kinds of U.S. Patent Documents*. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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				Application Number	Herewith
				Filing Date	
				First Named Inventor	Chen et al
				Group Art Unit	
				Examiner Name	
Sheet	3	of	6	Attorney Docket Number	100202586-5

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT					
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Sheet	4	of	6	Application Number	Herewith
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				First Named Inventor	Chen et al
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				Attorney Docket Number	100202586-5

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS		
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 5 of 6

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Application Number	Herewith
Filing Date	
First Named Inventor	Chen et al
Group Art Unit	
Examiner Name	
Attorney Docket Number	100202586-5

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

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Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/280,995	CHEN ET AL.	
Examiner		Art Unit		6 of 6
Jack Dinh		2873		

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
X	A	US-5,012,090	04-1991	Spillman, Jr., William B.	250/237G
X	B	US-2002/0196548	12-2002	Fabiny, Larry	359/571
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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